

I hereby certify that this correspondence is being sent by facsimile to 1-571-273-8300 addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.
Dated: May 28, 2008 Signature: *Eileen Sheffield*
(Eileen Sheffield)

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MAY 28 2008

Docket No.: NY-RPP-202
(10510421)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
BECKMANN

Application No.: 10/552,677

Group Art Unit: 1792

Filed: November 21, 2005

Examiner: N. K. Ford

For: HIGH FREQUENCY PLASMA JET SOURCE
AND METHOD FOR IRRADIATING A
SURFACE

NOTICE REGARDING SMALL ENTITY STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant asserts that he is entitled to small entity status. Please update the USPTO records accordingly.

Dated: May 28, 2008

Respectfully submitted,

By *James R. Crawford*
James R. Crawford
Registration No.: 39,155
FULBRIGHT & JAWORSKI L.L.P.
666 Fifth Avenue
New York, New York 10103
(212) 318-3000
(212) 318-3400 (Fax)
Attorney for Applicant